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APPLICATION NO. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/689,855 10/22/2003		Masanobu Shigeta	21994-00064-US 4217		
30678	7590 09/07/2005		EXAMINER		
	Y BOVE LODGE & H	QI, ZHI	QI, ZHI QIANG		
SUITE 800 1990 M STR	EET NW		ART UNIT	PAPER NUMBER	
	ON, DC 20036-3425	2871			

DATE MAILED: 09/07/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application	n No	Applicant(s)				
			•	SHIGETA ET AL.				
Office Action Summary		10/689,85		Art Unit				
		Examiner						
	The MAIL INC DATE of this communi	Mike Qi	saver cheet with the o	2871	Idross			
Period fo	The MAILING DATE of this communi or Reply	cauon appears on tre	cover sneet what the c	orrespondence ad	uress			
THE - External after - If the - If NC - Failu Any (ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNION Assions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this community period for reply specified above is less than thirty (30 period for reply is specified above, the maximum state to reply within the set or extended period for reply very reply received by the Office later than three months after a patent term adjustment. See 37 CFR 1.704(b).	CATION. of 37 CFR 1.136(a). In no eventurication. of ays, a reply within the statutory period will apply and within the statutory period will.	ent, however, may a reply be time story minimum of thirty (30) days Il expire SIX (6) MONTHS from ication to become ABANDONE	rely filed s will be considered timel the mailing date of this c O (35 U.S.C. § 133).	ly. ommunication.			
Status	•							
1) 又	Responsive to communication(s) filed	d on <i>25 July 2005</i> .						
,	, ,	b)☐ This action is n	on-final					
3)		•		secution as to the	e merits is			
<u>ا</u> رد								
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims								
-	Claim(s) <u>2 and 3</u> is/are pending in the application.							
	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)[Claim(s) is/are allowed.							
6)⊠	Claim(s) <u>2 and 3</u> is/are rejected.							
7)	Claim(s) is/are objected to.							
8)[Claim(s) are subject to restrict	tion and/or election re	equirement.					
Applicati	ion Papers							
9)	The specification is objected to by the	Examiner.						
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
,	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
,	•	•						
-	under 35 U.S.C. § 119		L. 051100 0 0 440(-)	(4) (6)				
,—	Acknowledgment is made of a claim f \boxtimes All b) \square Some * c) \square None of:	for foreign priority und	der 35 U.S.C. § 119(a))-(d) or (t).				
,	1.⊠ Certified copies of the priority documents have been received.							
	2. Certified copies of the priority			on No				
	3. Copies of the certified copies of	of the priority docume	ents have been receive	ed in this National	Stage			
	application from the Internation				_			
* 5	See the attached detailed Office action	·		ed.				
Attachmen	t(s)							
	ce of References Cited (PTO-892)		4) Interview Summary	(PTO-413)				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)					0.450)			
· —	mation Disclosure Statement(s) (PTO-1449 or Property No(s)/Mail Date	PTO/SB/08)	5) Notice of Informal F 6) Other:	ratent Application (PT	U-152)			

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 2 and 3 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 6,426,786 B1 (Lu et al) in view of US 5,030,322 (Shimada et al).

Regarding claims 2 and 3, Lu discloses (col.4, line 19 – col.5, line 58; col.1, line 24 – col.2, line 15; Figs.1-3) that a method of forming an alignment layer of a liquid crystal display cell comprising:

- displacing a base (substrate 28) in a filming apparatus (thin film deposition system 20) used for forming an angle-deposited film to accomplish the desired alignment (col.5, lines 9-22; Fig.2);
- conducting a vapor stream of a material for an inorganic alignment layer (silicon dioxide) displaced in the filming apparatus (thin film deposition system 20) so as to enter into the base (substrate 28) at an angle (evaporation angle) of 30 to 50 degree (col.5, lines 23-58; Fig.2);
- forming the inorganic alignment layer on the base so as to conduct a pre-tilt angle of liquid crystals to be about 0.2 to about 10 degree.

Although Lu does not explicitly disclose the evaporation angle is 40 to 60 degree

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and the pre-tilt angle is 3 to 10 degree, the ranges as shown in Lu are close and overlap. In the case where the claimed ranges "overlap or lie inside range disclosed by the prior art" a prima facie case of obviousness exists. (MPEP 2144.05. I.)

Lu does not explicitly disclose that introducing <u>oxygen gas</u> into the filming apparatus at a prescribed gas pressure.

Shimada discloses a method of forming orientation film in which the gas feeding is designed to introduce oxygen as a desired gas (see col.6, lines 2-5; Fig.5), and adjust the gas pressure such as 5×10^{-4} torr, that is a prescribed gas pressure (see col.5, line 64 - col.6, line 2; Fig.5), and the ordinary skilled in the art would adjust it to a proper gas pressure according to the operation conditions such as 6×10^{-3} to 3×10^{-2} Pa. Shimada also indicates that such method easily control the thickness of the film (seecol.6, line 54 - col.7, line 8).

Therefore, it would have been obvious to those skilled in the art at the time the invention was made to modify the alignment layer forming method of Lu with the teachings of using oxygen gas as taught by Shimada so as to easily control the thickness of the film, since using vacuum evaporation and desired oxygen gas (see col.6, line 54 – col.7, line 8).

Response to Arguments

3. Applicant's arguments with respect to claims 2 and 3 have been considered but are most in view of the new ground(s) of rejection.

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Conclusion

4. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

- 5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- 6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mike Qi whose telephone number is (571) 272-2299. The examiner can normally be reached on M-T 8:00 am-5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mike Qi August 25, 2005

DUNG T. NGUYEN
PRIMARY EXAMINER